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School on Synchrotron and Free-Electron-Laser Sources and their Multidisciplinary Applications

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Introduction to X-ray microscopy and ray microscopy and spectro-microscopy

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Introduction to X-ray microscopy and spectro-microscopy

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•Materials have properties varying at various depth and length scales. •Structure and chemical composition usually is different at the surface nposition usually is
erent at the surface
and in the bulk. and in the bulk. •New properties expected with decreasing their dimensions.

What we NEED:

 Spatial resolution & chemical sensitivity, morphology & structure, varying probing depth, temporal resolution..

Why using synchrotrons for microscopy?

 $\overline{\textsf{Only 'LIGHT' with comparable wavelength, }\lambda_{\star}}$ can visualize the \vert micro- and nano-structured world

Synchrotron Light

- $\frac{1}{2}$ High brightness.
- $\frac{1}{2}$ **Tunability**
- * Polarization.
* Time structu
- * Time structure.
* Coherence
- * Coherence.

Modern technology

- **× X-ray focusing optics.**
★ **X** now an electron det
- \times X-ray or electron detectors.

X-Rays compared to charged particles: Rays

- \blacktriangleright Higher penetration power: wave-lenght controlled.
- > Great variety of spectroscopies-elemental, chemical etc information.
- Variety of imaging contrasts with diffraction limited resolution.
- Less sensible to sample environment.

Interactions of x-rays with the matter: redirection & <u>absorption \Rightarrow x-ray transmission</u>
and x-ray or electron emission <u>and x-ray or electron emission</u>

Synchrotrons offer a variety of spectroscopy and imaging approaches

Sampling depths depend on the detected signal (electrons or photons)

bulk

X-ray

 $E=E_2-E_1=L_\alpha$ or

x-ray

 $\Delta E = E_3 - E_1 = L_6$

X-ray microscopes using photon or electron optics $\,$

X-ray focusing optics: zone plates, mirrors, capillaries

Zone Plate optics: from \sim 200 to ~ 10000 eV Resolution: 20 nm in transmission

KP-B mirrors each focusing in one direction: soft & hard: ~ 1000 nm Soft & hard x-rays! chromatic focal point, easy energy tunability, comfortable working distanceResolution ≤ 100 nm

Normal incidence: spherical mirrors with multilayer interference coating (Schwarzschild Objective) not tunable, E < 100 eVResolution: best ~ 100 nm

Capillary: multiple reflection concentrator

Hard x -rays \sim 8-18 keV Resolution: > 3000 nm

Refractive lenses

Hard x -rays \sim 4-70 keV V Resolution: > 1000 nm

Imaging and $\boldsymbol{\mu}$ -spectroscopy

- 1) morphology (x-ray contrast based on absorption, scattering, refraction etc);
- 2) elemental composition;
- 3) chemical states;
- 4) magnetic spin or bonding orientation;
- 5) band bending, charging, etc.

 characterization of the chemical and electronic structure of the coexisting micro-phases: µ-PES, XANES & FS

Imaging x-ray transmission microscope (TXM)

2009 - XTM (10+3): – ALS (2), APS (2), BESSY II (1), ELETTRA (1), ESRF (1), ASTRID (1), SPRING'8 (1), AURORA (1), DIAMOND(1), SOLEIL (1), ALBA (1). Resolution achieved 15 nm.

Imaging and spectro-microscopy with FFIM

Trabecular bone of a mouse femursample $(10\mu m$ thick); Image field is 27 \times 21 μ m²

Study dealing with genetic determinism of immobilization induced bone loss with the FFIM at ID21, ESRF, France

Hydroxy-apatite spectrum recovered from astack of 200 images

Cell imaging in their natural environment: the cells contain C and N and absorb an order of magnitude more strongly than the surrounding water when using x-rays below the O edge (540 eV, 'water window'). The resulting natural contrast generates unprecedented views of the internal cellular architecture in a natural, albeit frozen, state, information crucial for understanding the cellular function: Tomography!!!

X-ray Scanning Microscopy: uses focusing x-ray optics (preferred zone plates)

History: The 1st experiments with lab source at SSR late 1970sNSLS-Stony Brook: Janos Kirz & Co. The first operating STXM - 1983, SPEM – 1990. x-ray detectors: spectroscopy & tomogrpahyx-ray area detector:Raster scanned diffraction sample Zone plate Exit slits Spherical grating m ono chromator Entrance sitts e⁻ or x-ray detector spectroscopyUndulator source 2008 - STXM and/or SPEM (17): – ALS (3), APS (2), BESSY2 (1), ELETTRA (3), ESRF (1), PLS (1), NSLS (1), SLS (1), SPRING'8 (1), SRRC (1), CLS (1), DIAMOND (1), Soleil (1). Resolution achieved 25 nm.

XANES imaging and spectroscopy with STXM

Polymer science: outlining the lateral distributionof PS/PMMA using the XANES fingerprints

Transmission x-ray micrographs

School on Synchrotron and Free-Electron-Laser Sources and their Multidisciplinary Applications, April 26-May 7 H. Ade et al, STXM at NSLS

TiO2-DNA nano-composites for in-vivo Gene Surgery: XRF maps

Chemical FS imaging is crucial to quantify the success rate and reveal the location of the single stranded nanoparticle in the cell chromosome

DNA-TiO2 particle crossing cell walls

X-ray contrast based on photon detection

CHEMICAL SENSITIVITY, VARYING PROBING DEPTH, MORPHOLOGY & STRUCTURE, VERSATILE SPECIMEN ENVIRONMENT

More details for the FFIM and STXM + XRF techniques and applications in the forthcoming lectures of Burkhard Kaulich

Low-dimensional materials and their unique properties

There's Plenty of Room at the Bottom

*An Invitation to Enter a New Field of Physics & Material Science*Richard P. Feynman- *1959!!!*

Surface 'geometric' structure

Surface Reflection of the Case of the Case of the Case of the Surface Surface the surface status controls physical and chemical properties

chemistry

Electronic properties and confinement effects

Spatial resolution with chemical and structural surface sensitivity are needed.

All information of PES at microscopic scales

- •Qualitative and quantitative elemental information: CL
- •Chemical composition and chemical bonding:CL & VB
- Electronic and magnetic structure (VB, ARUPS, PED, XMCD-XMLD with secondary electrons (XANES).
- •Information depth < 10 nm (surface sensitive)

SPEM characterization of MoS₂-nanotubes

Twisted chiral bundles of Mo-S individual cylinders: Mo 3d maps

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SPEM revealed I (used as a carrier) in interstitial positions between the tubes bonded to the outer S atoms.

Due to the low dimensionality the S 2p, Mo 3d and VB spectra are positiondependent and reflect electronic properties significantly different those of the MoS $_2$ crystal.

More details for the SPEM technique and applications in the forthcoming lectures of Luca Gregoratti

Scanning photoelectron microscopy with ARUPS at Elettra

π-band dispersion of HOPG

Binding energy (eV)

ARPES microscope: orientation disorder of graphite flakes

X-ray Imaging PhotoEmission Electron Microscopy (XPEEM) (+ LEEM)

History: PEEM-early 1930s, XPEEM late 1980s Ernst Bauer (Uni Claustal), W. Engel (FHI-Berlin).B. Tonner (SRC)The 1st XPEEM with energy analyser (XPS&XAS) – early 1990s

2006- XPEEM (19): ALS(1), APS(1), BESSY II (2), ELETTRA (1), NSLS (1), PLS (1), SPRING'8 (2), SLS (1*), SRRC (1), SRS(1), MAXLab (1*), CLS (1*), SOLEIL(1), DIAMOND (1), APS (1), Alba (1). Resolution achieved 20 nm.

LEEM-XPEEM: Mg Films on W(110) Thickness-Electron Confinement-Oxidation rate

More details for the XPEEMtechnique and applications in the forthcoming lectures of Andrea Locatelli

SPEM

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 Fe_{719eV} —
—Μ↑↑σ_{ημ}
—Μ↑↓σ...

- + Full power of XPS
- + Spectro-imaging.
- + Flexible sample geometry and FOV.
————————————————————
- + Insensitive to sample roughness;
- Fast processes or XANES.
- Lateral resolution (50 nm)-
- + Lateral resolution (<5nm imaging)
- + Dynamic studies;
- + XANES, PED&ARUPS.
- + LEEM & m-LEED: structure
- XPS spectral resolution
- sample roughness and size.

Carbon nanotubes with SPEM and XPEEM: C 1s images and spectroscopy

1 µm

XPEEM: only flat samples

Valence band and C1s spectra evidence different local electronic structures at the sidewalls andon at the tips of MWCT: higher DB density on spherically curved tips & defects?

S. Suzuki et al, Phys. Rev B66, 35413 Carbon 42, 559, 35413, JESRP 144, 357

Classical X-ray imaging and
rates wissessesses heigh seetling spectromicroscopy; brief outline

SURFACES & INTERFACES:XPEEM and SPEM

PHOTON IN/ ELECTRON OUT PHOTON IN/ PHOTON OUT (probing depth=f(E_{el}) max ~ 20 nm)

Spectroscopy (XPS-AES-XANES)

ONLY CONDUCTIVE SAMPLES

<u>Total e⁻ yield</u> (sample current) XANES

- Chemical surface sensitivity: Chemical bulk sensitivity Quantitative µ-XPS (0.01 ML) $>$ Chemical & electronic (VB) structure Trace element mapping

 BULK SAMPLES<u>STXM-SPEM-TXM</u>

(probing depth = f $(E_{\rm ph}) > 100$ nm)

(Spectroscopy – XFS or XANES)

Total hv yield, Transmitted x x-rays

Quantitative μ -XFS

- X-ray microscopes monitoring electrons limited to surfaces and resolution depending on the focusing or electron optics
- X-ray microscopes monitoring ^photons (scanning, full fiel d imaging microscopes) – depth information but limited in lateral and depth resolution by the optical elements: repetition rateand coherence to be considered.
- Electron microscopes, e.g TEM can resolve even atoms but are - $\frac{limited\ in\ penetration}{camplex\ thinner\ than} \sim 30\ nm$).

The depth-resolution limitations can in principle be overcome by image reconstruction from measured <u>coherent</u> X ray diffraction pattern: the pattern of the sample is recorded with no optics-imposed resolution limits, i.e. the resolution is only diffraction (wavelength) limited.

Exploiting the coherence: Coherent Diffraction Imaging

Based upon the principle of coherent scattering in combination with a method of direct phase recovery called oversampling.

- > The scattered amplitude is a Fourier transform of (complex) electron density $f(r)$: F(k) = $\int f(r) e^{-2\pi i k}$ r dr
	- J. Miao et al, *J. Opt. Soc. Am. A* 15, 1662.
- > Phase information retrieved by iterative algorithms applied to oversampled Phase information retrieved by iterative
algorithms applied to oversampled
diffraction pattern, or through a maskbased holographically formed interference pattern.

Avoids ~100x signal loss of lenses and can go beyond
numerical aparture limit of available aptics numerical aperture limit of available optics.

 Challenge: algorithms for reconstruction of the holography patterns.

Synchrotron undulator radiation:

 $FERNI$

 pinhole and monochromators are used for spatial and spectral filtering, but the at the expense of intensity!

FEL: natural coherenceeach electron emits spontaneous emission that overlap each other in phase

Time scales for 'non-destructive' flash imaging: get information in a single shot!

 \Rightarrow With an of pulse length < 50 fs and 3 x 10¹² photons focused down
a spot of \approx 0.1 um, a 2D diffraction pattern can be recorded before to a spot of \sim 0.1 μ m, a 2D diffraction pattern can be recorded before the radiation damage manifests itself.

More details for the CDI technique and applications using synchrotrons and FELs in the forthcoming lectures of Janos² Kirz and Hajdu

Infrared Specromicroscopy

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Enjoy the following Lectures

THE REAL

X-ray microscopy: absorption & phase contrast(lectures Kaulich)

- 2D/ 3D morphology
	- High resolution.
	- Density mapping.

Photoelectron Spectromicroscopy:(lectures Gregoratti-Locatelli)

- Chemical state
- Chemical mapping.
- Surface sensitive.

X-ray Absorption Spectromicroscopy(<mark>lectures Locatelli-Kaulich)</mark>

- Short range structure.
- Electronic and magnetic structure.
	- Chemical mapping.
- Depth information determined by the collected signal – electrons or photons

X-ray (Coherent) Scattering(lectures Kirz-Hajdu) •Structure: stress/strain/texture 2D/3D mapping.• Chemistry at resonances

Infrared Spectromicroscopy(lectures Dumas-Vaccari-Perucchi) •Molecular groups and structure •High S/N for organic matter•Functional group imaging. •Modest resolution but nondestructive radiation.

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Microscopy @ Elettra: visit May 6th

